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TO:	UNITED STATES PATENT AND TRADEMARK OFFICE GROUP ART UNIT:2813		
FAX NO.:	703-872-9318		
COMPANY:	N/A		
OUR FILE NO.:	JC-7109-CIP		
CLIENT NAME:	JCIPO		
TOT. PAGES:	6	SENT BY:	JM
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SUBJECT: PRELIMINARY AMENDMENT

Re: U.S. Patent Application

Title : POST-CMP REMOVAL OF SURFACE CONTAMINANTS
FROM SILICON WAFER
Attorney Docket No. : JC-7109-CIP
Filing Date : JUNE 24, 2003
Serial No. : 10/603,924

MESSAGE:

Please acknowledge receipt of this Preliminary Amendment via fax confirmation to (949) 251-1588.



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No.	Doccode	Number of pages
1	DIST	3
2	LET.	2
3	IMIS	1

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